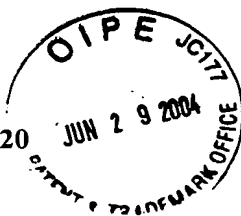


Attorney Docket No. 081468-0308420
Client Reference: P-1522.010-US



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sven Antoin Johan HOL, Edwin Johan BUIS, Harmen Klaas VAN DER
SCHOOT, Patricia VREUGDEWATER

Application No.: 10/797,618
Filed: March 11, 2004

Confirmation No: 6457
Group No.: TBA
Examiner TBA

For: LITHOGRAPHIC ACTUATOR MECHANISM, LITHOGRAPHIC APPARATUS, AND
DEVICE MANUFACTURING METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76(c)

BIBLIOGRAPHIC DATA

1. Applicant information is being modified:

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Date: June 29, 2004

A handwritten signature in black ink, appearing to read "Rico Hernandez", written over a horizontal line.

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